



Attorney Docket No.: 033082M257

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 9221

Applicants : Masanobu HONDA, et al.
U.S. Serial No. : 10/538,064
Filed : March 7, 2006
Examiner : Maki A. Angadi
Group Art Unit : 1765
For : METHOD AND APPARATUS FOR
PLASMA-ETCHING ORGANIC MATERIAL FILM

AMENDMENT SUBMITTED WITH
REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on May 11, 2007, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is being submitted with a Request for Continued Examination ("RCE") and a check for the sum of \$790, in payment of the RCE fee.